

Electronic Acknowledgement Receipt

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Application Number:	10725744
Confirmation Number:	3066
Title of Invention:	SYSTEMS FOR INSPECTING WAFERS AND RETICLES WITH INCREASED RESOLUTION
First Named Inventor:	Steven R. Lange
Customer Number:	35617
Filer:	Kevin L. Daffer/Pamela Gerik
Filer Authorized By:	Kevin L. Daffer
Attorney Docket Number:	5589-05201 P1067
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Post Allowance Communication - Incoming	Comments_NOA.pdf	85929	no	1

Warnings:**Information:****Total Files Size (in bytes):**

85929

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.